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formation Disclosure Statement (IDS) Filed

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	Application Number		10519337	
	Filing Date		2004-12-22	
INFORMATION DISCLOSURE	First Named Inventor Nancy		cy Dean	
STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Art Unit		1794	
(Not for submission under 37 Of it 1.33)	Examiner Name	Kevin	R. Kruer	
	Attorney Docket Number		H0004275.68586 US - 4018	

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Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear			
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /K.K./

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Application Number 10519337 Filing Date 2004-12-22 INFORMATION DISCLOSURE First Named Inventor Nancy Dean STATEMENT BY APPLICANT Art Unit 1794 (Not for submission under 37 CFR 1.99) **Examiner Name** Kevin R. Kruer Attorney Docket Number H0004275,68586 US - 4018 20020185734 Α1 2002-12-12 Sam Zigun Zhao If you wish to add additional U.S. Published Application citation information please click the Add button. FOREIGN PATENT DOCUMENTS Pages, Columns, Lines Name of Patentee or Cite Foreign Document Examiner Country Kind Publication where Relevant Applicant of cited **T**5 Initial* Number³ Code2i No Code4 Date Passages or Relevant Document Figures Appear 1 If you wish to add additional Foreign Patent Document citation information please click the Add button **NON-PATENT LITERATURE DOCUMENTS** Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item Cite Examiner (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), **T**5 Initials* No publisher, city and/or country where published. If you wish to add additional non-patent literature document citation information please click the Add button **EXAMINER SIGNATURE** 01/14/2009 **Examiner Signature** Date Considered /Kevin Kruer/ *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. 2 Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). 3 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

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English language translation is attached.